

Progress meeting

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08/04/2013

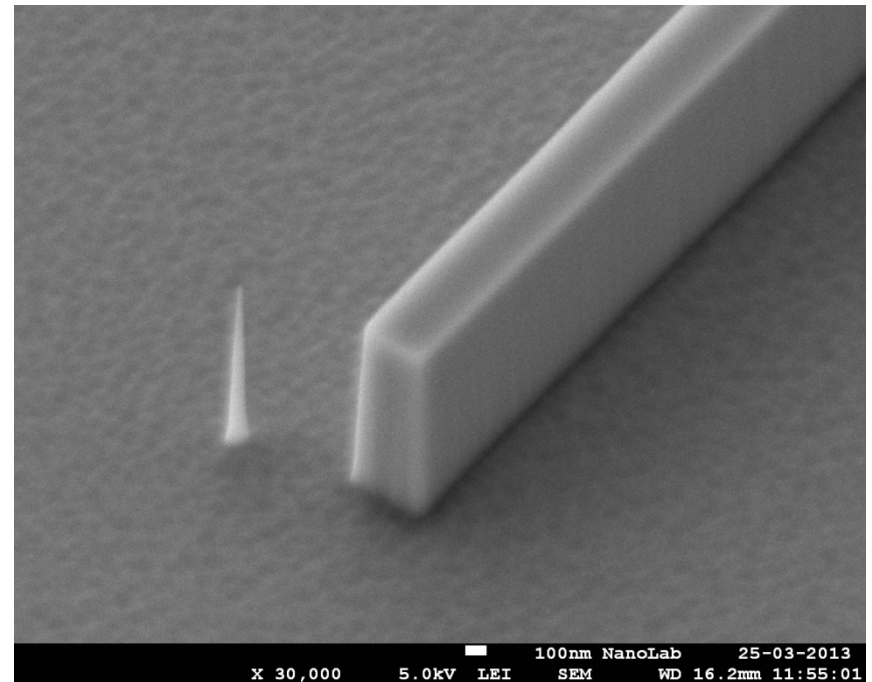
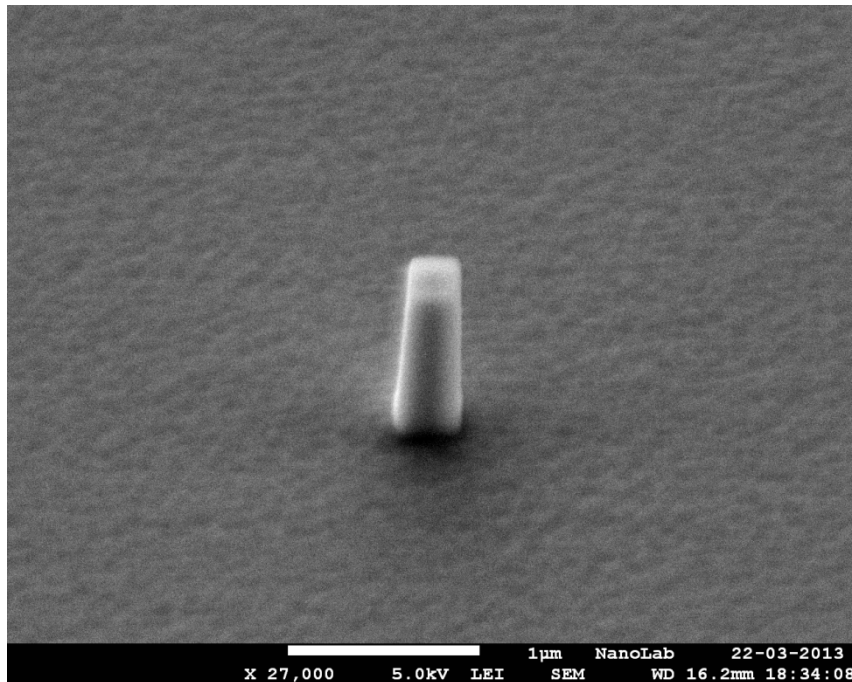


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Where innovation starts

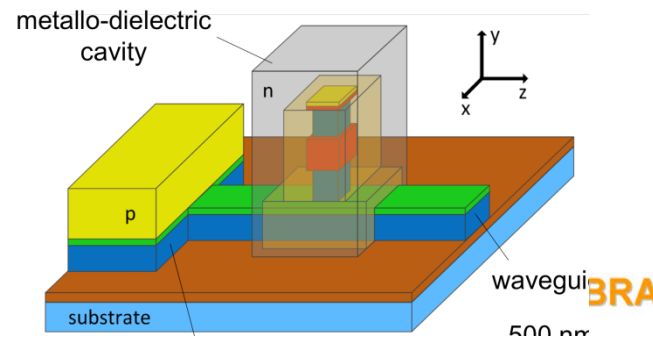
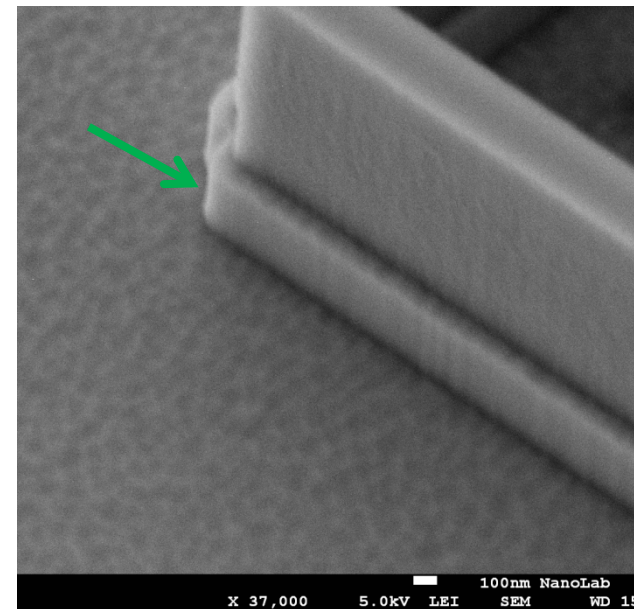
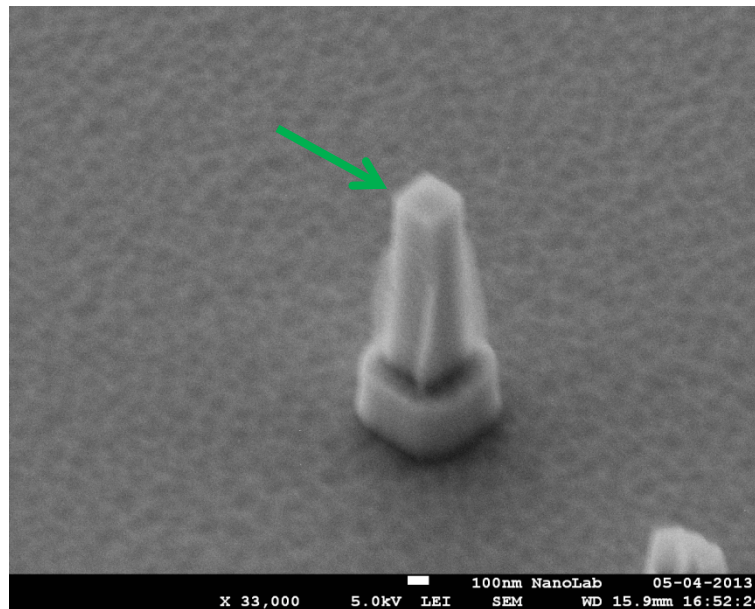
New experiments

- Again able to etch pillars and ridges using HSQ resist



Self-masking etching

- Investigation of self-masking scheme (structures fabricated with a single EBL step)



Milestones and deliverables

MS13	Initial characterization of unbonded plasmonic lasers	04/2013
	<p>→ We will prepare either a document to merge MS13 and MS15 or we will just explain the reasons of the delay once both MS are achieved. Any suggestion/preference?</p>	
D7.3	Mirror Deliverable of D7.1, which will be available to the public on the website.	04/2013
	<p>→ Waiting for ST to deliver 7.1</p>	



Other issues

- UGhent will receive III-V samples to bond to Silicon this week
 - → Then experiments on bonded wafers can be started
- Meeting in Karlsruhe
 - Only Victor is attending

